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TRANSMITTAL FORM (to be used for all correspondence after initial filing)		Application Number	09/994,279
		Filing Date	November 26, 2001
		First Named Inventor	Tony P. Chiang
		Group Art Unit	2818
		Examiner Name	David Nhu E
Total Number of Pages in This Subm	ission 14	Attorney Docket Number	PA1688US 6 9 9
ENCLOSURES (check all that apply)			
Fee Transmittal Form Fee Attached X Amendment / Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement Certified Copy of Priority Document(s) Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53	CD, Nui	g-related Papers to Convert to a nal Application of Attorney, Revocation of Correspondence Il Disclaimer t for Refund mber of CD(s)	After Allowance Communication to Group Appeal Communication to Board of Appeals and Interferences Appeal Communication to Group (Appeal Notice, Brief; Reiply Brief) Proprietary Information Status Letter Other Enclosure(s) (please identify below): Postcard, Letter to Chief Draftsman.
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IN THE

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT:

Tony P. Chiang et al.

SERIAL NO.:

09/994,279

FILING DATE:

November 26, 2001

TITLE:

Method for Integrated In-Situ Cleaning and

Subsequent Atomic Layer Deposition Within a Single

TECHNOLOGY CENTER 2800

Processing Chamber

EXAMINER:

David Nhu

GROUP ART UNIT:

2818

CONFIRMATION NO.

8825

ATTY.DKT.NO.:

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AMENDMENT AND RESPONSE

Dear Sir:

In response to the Office Action dated June 27, 2002 please amend the above-identified application as follows:

IN THE CLAIMS:

Please remove from examination and cancel, without prejudice, claims 14-

16, 18, 20, and 21.